

7. (Amended) The position indicator of Claim 2, wherein the elastic film is comprised of a piezoelectric film having a piezoelectric effect.

8. (Amended) The position indicator of Claim 7, wherein the piezoelectric film is glued to another film, comprised of a material with good elasticity and rigidity, which fills a role of pushing air.

9. (Amended) The position indicator of Claim 2, wherein the reaction of the air due to the movement of the position indicator is calculated by measuring a change in an output of a photo sensor which receives a reflected light of a light emitted towards the elastic film.

10. (Amended) The position indicator of Claim 2, wherein the elastic film is comprised of a silicon, a piezo resistive element is set near the elastic film and a deflection occurred by the elastic film pushing the air is measured by a change in a resistance value of the piezo resistive element.